

MS PETITION
Docket No.: 3885-0102P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hisashi YAMADA et al.

Application No.: 10/046,739

Confirmation No.: 2551

Filed: January 17, 2002

Art Unit: 2814

For: THIN-FILM CRYSTAL WAFER HAVING PN
JUNCTION AND METHOD FOR FABRICATING
THE WAFER

Examiner: H. B. Trinh

SECOND STATUS INQUIRY


MS Petition
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive a Response for the Petition to Withdraw Abandonment filed on July 15, 2005 in the Patent and Trademark Office.

Dated: May 22, 2009

Respectfully submitted,

By 
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